

<b>Notice of References Cited</b>	Application/Control No. 10/802,772	Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Tai Duong	Art Unit 2871	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,574,487	06-2003	Smith et al.	455/566
*	B	US-2002/0176036	11-2002	Kaneko, Yasushi	349/65
*	C	US-2005/0046768	03-2005	Wu, Heng Chung	349/065
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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